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SUBCLASS 779

U.S. UTILITY Patent Application

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PATENT DATE

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APPLICATION NO.	CONT/PRIOR	CLASS	SUBCLASS	ART UNIT	EXAMINER
09/902056	D	438	779	2809	Sarkar

APPLICANTS
TITLE

Rao Annaprasada

Method of improving adhesion of cap oxide to nanoporous silica for integrated circuit fabrication

PTO-2040
12/89

☐ The term of this patent

☐ The term of this patent
has expired beyond the expiration date
of the patent No.

☒ The terminal months of
this patent have been disclaimed.

(Primary Examiner)

(Act)

(Legal Instruments Examiner)

(Act)

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